

00862.022183



Certificate  
MAR 1 2006  
of Correction

*CofC*  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

Haruhito ONO et al. )  
Application No.: 09/819,737 ) Examiner: I. M. Soward  
Filed: March 29, 2001 )  
For: ELECTROOPTIC SYSTEM ARRAY, CHARGED- ) February 23, 2006  
PARTICLE BEAM EXPOSURE APPARATUS :  
USING THE SAME, AND DEVICE )  
MANUFACTURING METHOD )  
U.S. Patent No. 6,965,153 B1 )  
Issued: November 15, 2005 )

**Certificate**  
**MAR 01 2006**  
**of Correc**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
**Attention: Certificate of Correction Branch**

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

Patentees note the following errors in the above-identified patent:

COLUMN 1:

Line 22, "suffers" should read -- suffers from --.

COLUMN 2:

Line 21, "ten" should read -- tens --.

These errors are relatively insignificant. Therefore, Patentees believe that filing a Request for Certificate of Correction is not warranted. Rather, Patentees request that this paper be placed of record in the official file of the subject patent.

Patentees believe no fee is due for filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed required.

Patentees' undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



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